

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**Applicant:** Divakaruni et al.

**Conf. No.:** 1387

**Serial No.:** 10/707,388

**Art Unit:** 2891

**Filed:** 12/10/2003

**Examiner:** Fulk, Steven J.

**Title:** SILICIDE RESISTOR IN BEOL  
LAYER OF SEMICONDUCTOR  
DEVICE AND METHOD

**Docket No.:** FIS920030274US1  
(IBMF-0032)

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

Sir:

**I. INTRODUCTORY COMMENTS:**

In response to the Final Office Action of October 11, 2007, please amend the above-referenced patent application as follows: